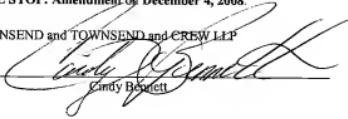


I hereby certify that this correspondence is being filed via  
EFS-Web with the United States Patent and Trademark Office  
**MAIL STOP: Amendment on December 4, 2008.**

TOWNSEND and TOWNSEND and CREW LLP

By:

  
Cindy Bennett

**PATENT**

Attorney Docket No.: 016301-047800US

Client Ref. No.: AMAT No.

007188/DISPLAY/AKT/BG

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Sheng Sun et al.

Application No.: 10/817,611

Filed: April 2, 2004

For: **METHOD AND SYSTEM FOR CONTROL  
OF PROCESSING CONDITIONS IN  
PLASMA PROCESSING SYSTEMS**

Customer No.: 57385

Confirmation No. 2449

Examiner: Bashore, Alain L.

Technology Center/Art Unit: 1792

**AMENDMENT**

**MAIL STOP: AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed September 4, 2008 (the "Office Action"),  
please enter the following remarks:

**A Listing of Claims** begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.